

## **Application Data Sheet**

### **Application Information**

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title::

METHOD FOR FORMING SILICON FILM WITH  
CHANGING GRAIN SIZE BY THERMAL  
PROCESS

Attorney Docket Number::

MXIC 1532-1

Request for Early Publication?::

No

Request for Non-Publication?::

No

Suggested Drawing Figure::

3

Total Drawing Sheets::

6

Small Entity?::

No

## **Applicant Information**

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: CHINA  
Status:: Full Capacity  
Given Name:: CHIH  
Middle Name:: YUAN  
Family Name:: HUANG  
City of Residence:: HSINCHU  
State or Province of Residence:: TAIWAN  
Country of Residence:: ROC  
Street of mailing address:: NO. 101 SI-TAI ROAD  
City of mailing address:: HSINCHU  
State or Province of mailing address:: TAIWAN  
Country of mailing address:: ROC

Applicant Authority Type:: Inventor  
Primary Citizenship Country:: CHINA  
Status:: Full Capacity  
Given Name:: JONASON  
Family Name:: CHEN  
City of Residence:: HSINCHU  
State or Province of Residence:: TAIWAN  
Country of Residence:: ROC  
Street of mailing address:: NO. 34 Sec. 2 Road Kun-Fu  
City of mailing address:: HSINCHU  
State or Province of mailing address:: TAIWAN  
Country of mailing address:: ROC

## **Correspondence Information**

Correspondence Customer Number:: 22470

## Representative Information

Representative Customer Number::	22470	
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- OR -

Representative Designation::	Registration Number::	Representative Name::

## Assignee Information

Assignee name::	MACRONIX INTERNATIONAL CO. LTD
Street of mailing address::	NO. 16 LI-HSIN ROAD
	SCIENCE-BASED INDUSTRIAL PARK
City of mailing address::	HSINCHU
State or Province of mailing address::	TAIWAN
Country of mailing address::	ROC